

## PATENT APPLICATION

Docket No.: N.C. 79,834

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of: Pique et al.

Serial No.: 09/619,442

Filed: 07/19/2000

For: DIRECT-WRITE LASER TRANSFER AND PROCESSING

Examiner: Fuller, Eric B.

Art Group Unit: 1762

Assistant Commissioner of Patents

Washington, D.C. 20231

March 4, 2003

## AMENDMENT

Sir:

This communication is responsive to the office action of 12/05/2002, setting a three month shortened statutory period of reply.

Please amend the claims as follows:

27. (New) The method of claim 15, wherein the first laser removes the source material from the surface of the support by matrix assisted pulsed laser evaporation direct write.
28. (New) The method of claim 26, wherein the pulsed laser beam removes the source material from the surface of the support by matrix assisted pulsed laser evaporation direct write.

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